

Status of NSLS II



F. Willeke, BNL
Particle Accelerator Conference 2011, New York City
March 29, 2011

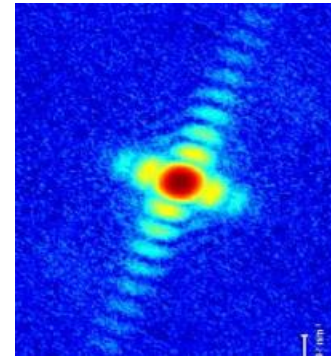
Outline

- Requirements
- Design
- Facility Status
- Injectors
- Critical Subsystems
- Insertion Devices
- Photon Beam Lines
- Construction Status
- Summary

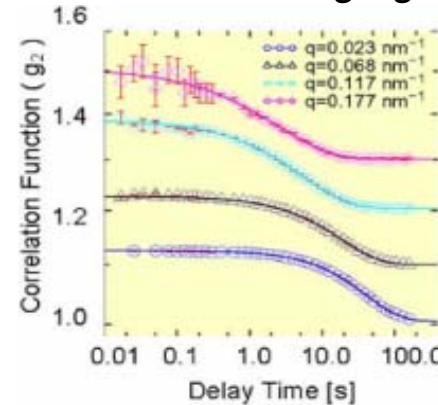


Mission

- NSLS: a very productive light source
4th decade of operation
Strong on-going science program
- State of the art of accelerator technology:
Factor 10⁴ increase in brightness,
Factor 10 increase in flux
→ More than a quantitative step
- 2005: DOE acknowledges mission need
for a synchrotron radiation facility with
1 nm spatial resolution
0.1 meV energy resolution
- Start of NSLS-II Project: 2005 CD 0
2007 CD 1
2008 CD2
2009 CD3
2015 CD4



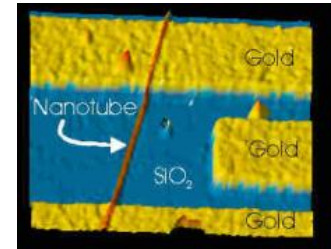
Diffraction Imaging



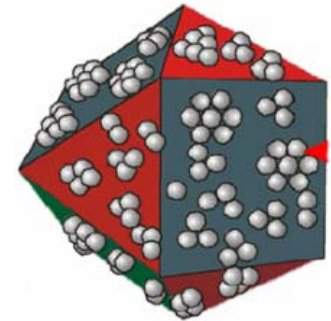
Coherent Dynamics



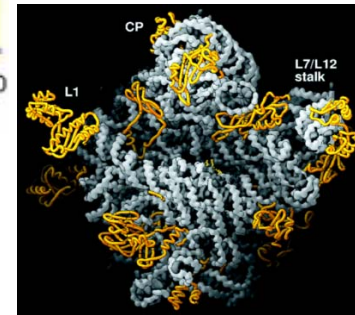
Nanoprobes



Nanoscience



Nanocatalysis



Life Science

Requirements

Average Spectral Brightness: $10^{21} \cdot \text{mm}^{-2} \cdot \text{mrad}^{-2} \cdot \text{s}^{-1} \cdot 0.1\% \text{bw}^{-1}$

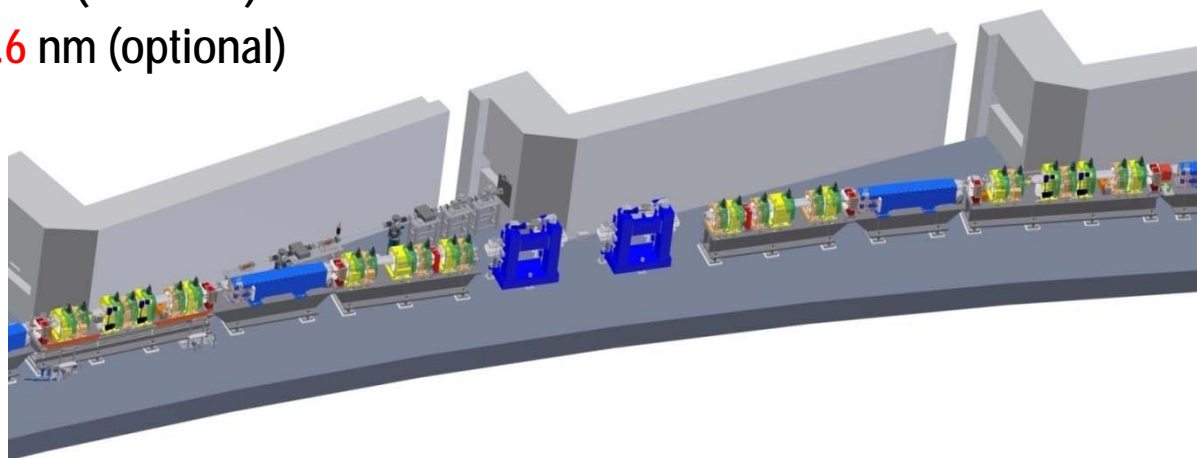
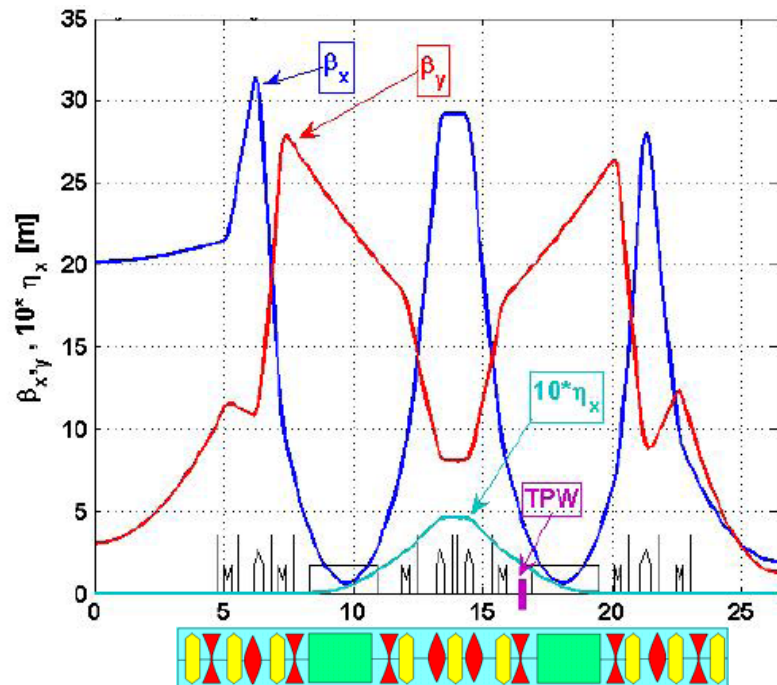
Spectral Flux Density : $10^{15} \cdot \text{s}^{-1} \cdot 0.1\% \text{bw}^{-1} @ 2 \text{ keV}$

Accelerator Main Parameters

beam energy:	3 GeV
beam intensity:	500mA
Intensity Stability	0.5% → Top-Off Injection mode
small beam emittance:	$\epsilon_x = < 1 \text{ nm rad},$ $\epsilon_y = 8 \text{ pm rad}$
orbital stability:	$\Delta y < 0.3 \text{ }\mu\text{m}$
RF Phase Stability	0.01 Degree
Number of beamlines	> 60

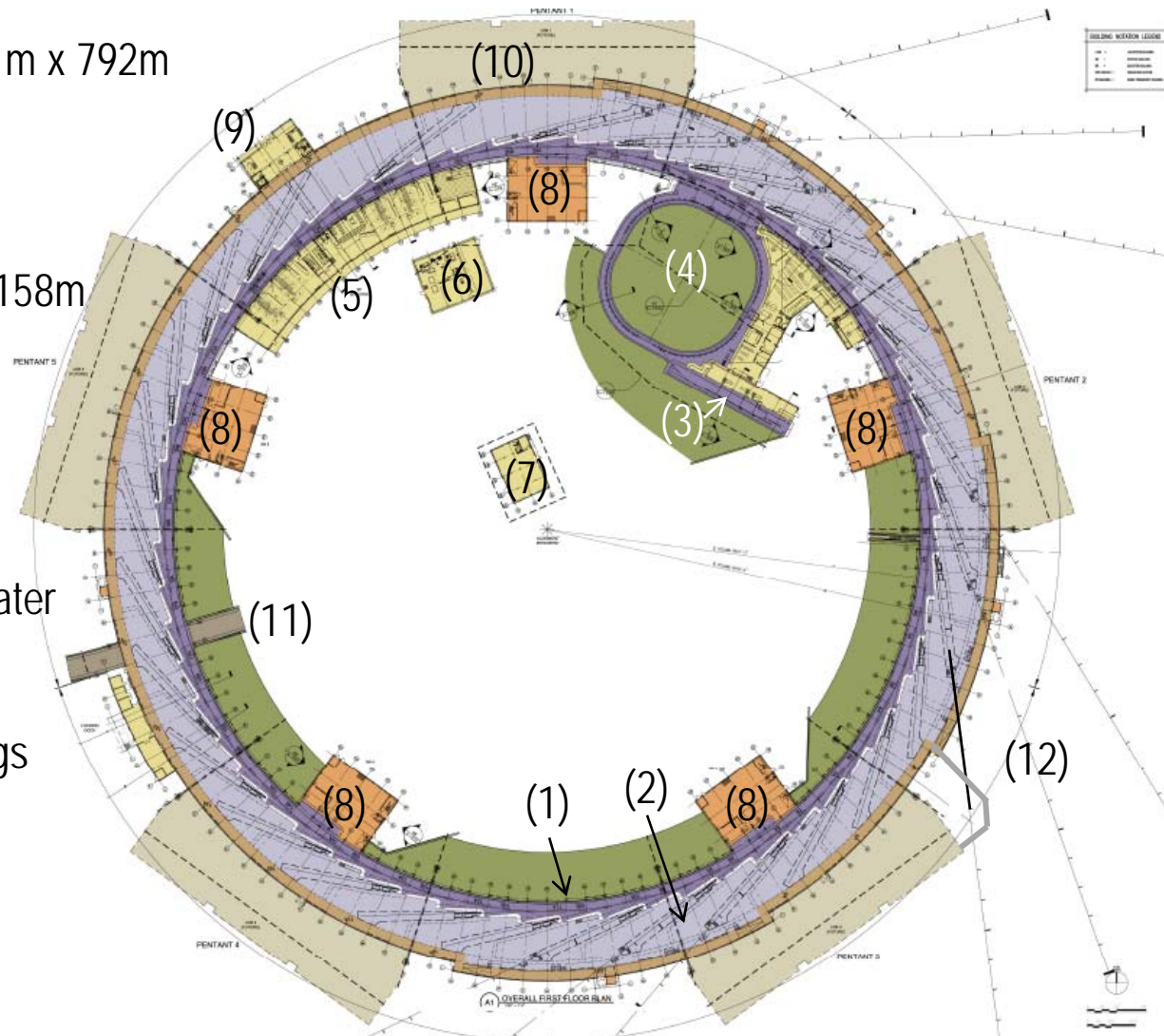
Low Emittance Lattice Design

- Large Circumference 792 m
30 DBA cells $\epsilon_x \sim N_{\text{cell}}^{-3}$
- Soft Bending Magnet $B = 0.4 \text{ T}$
 $\beta_{x-\text{max}} \sim \xi \sim 1 / L_{\text{bend}}$
→ Achieve close to theoretical minimum emittance without excessive chromaticity $\epsilon_x = 2 \text{ nm}$
- Soft bend, low radiation loss Emittance $\sim 1/\rho$
low radiation loss, 283 keV/turn/electron
→ efficient use of **damping wigglers** to reduce emittance by increased betatron damping rate
3 x 2 x 3.5 m wiggler @ 1.8 T: $\epsilon_x = 1 \text{ nm}$ (baseline)
8 x 2 x 3.5 m wiggler @ 1.8 T: $\epsilon_x = 0.6 \text{ nm}$ (optional)

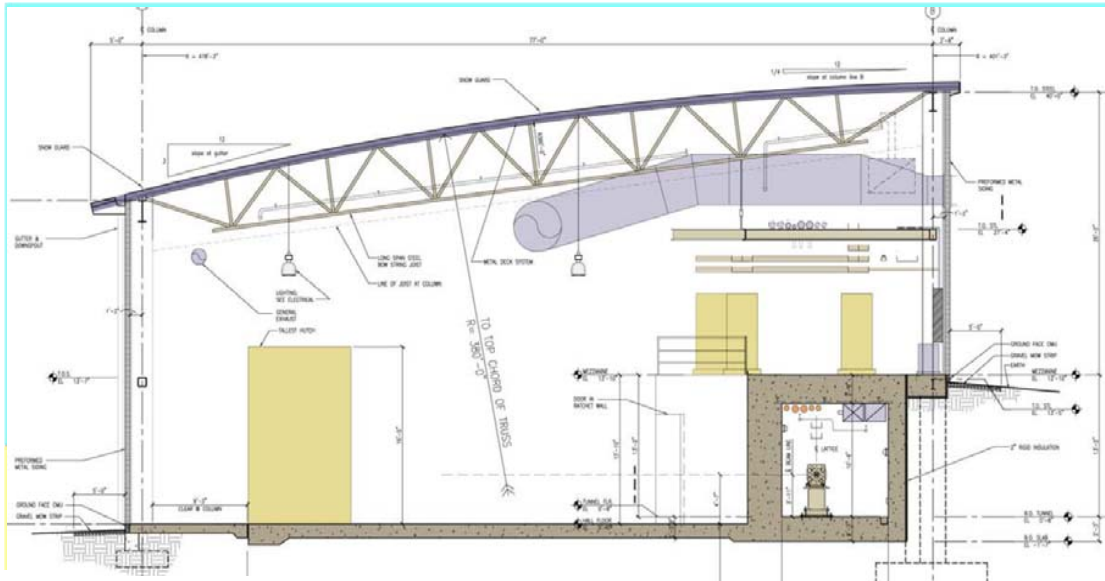


Facility Overview

- (1) Accelerator Tunnel 3.7m x 3.2 m x 792m
- (2) Experimental Floor, width 17m
- (3) 200MeV S-Band LINAC
- (4) 3GeV Booster Synchrotron C=158m
- (5) RF Building, Iq. He Plant
- (6) Compressor Building
- (7) Central Cooling Tower
- (8) Service Buildings: HVAC, DI water
- (9) Lobby
- (10) Laboratory and Office Buildings
- (11) Vehicle underpass
- (12) Extra long beam line



Facility Overview



Storage Ring Tunnel

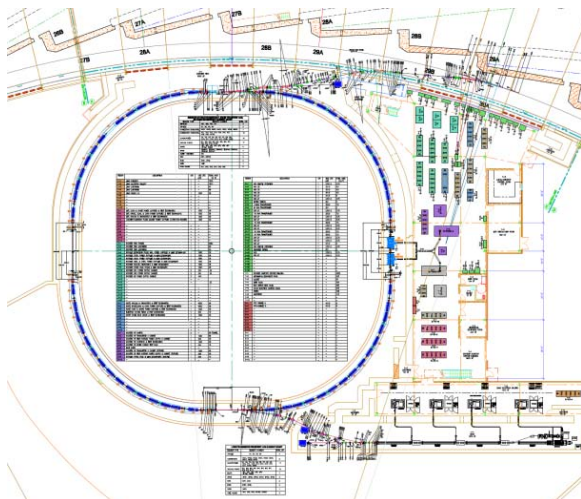
Staged Availability Building

1 st pentant:	Mar 15 '11
RF	May 18 '11
Injector	Jul 28 '11
2 nd Pentant	Jun 2 '11
3 rd Pentant	Sep 27 '11
4 th Pentant	Nov 28 '11
5 th Pentant	Feb 9 '12



NSLS-II INJECTOR

on-energy top-off injection with 1/min top-off rate



200 MeV LINAC

Frequency S-Band

Charge 15nC

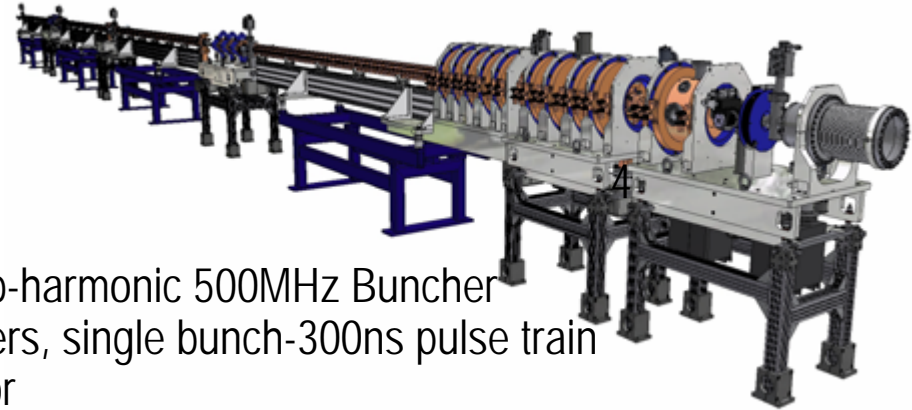
$\Delta E/E$ <1%

sectors

Thermionic Gun Sub-harmonic 500MHz Buncher

Variable bunch patterns, single bunch-300ns pulse train

Solid state modulator



3 GeV Booster

Combined Function Lattice

Circumference 158m

Injection Energy 200MeV

Extraction Energy 3GeV

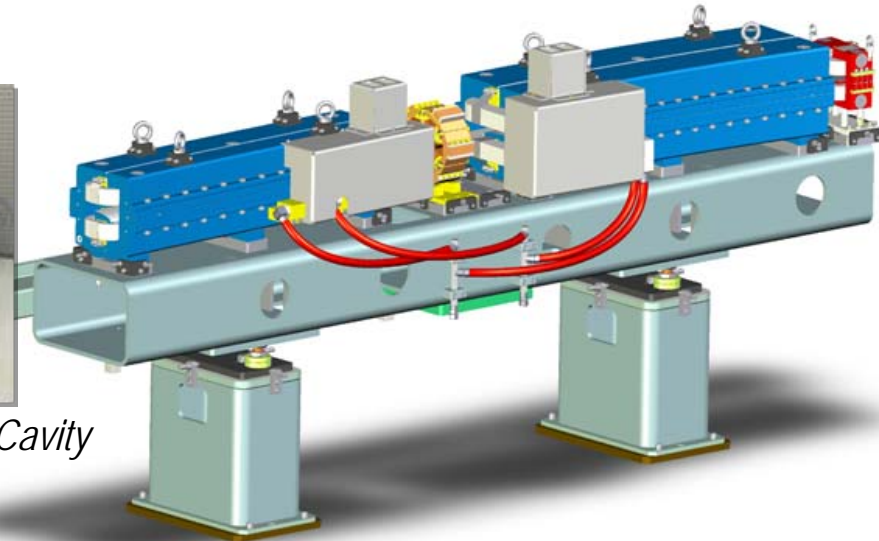
Cycle Frequency 1Hz

Charge 10-15nC

@20-30mA

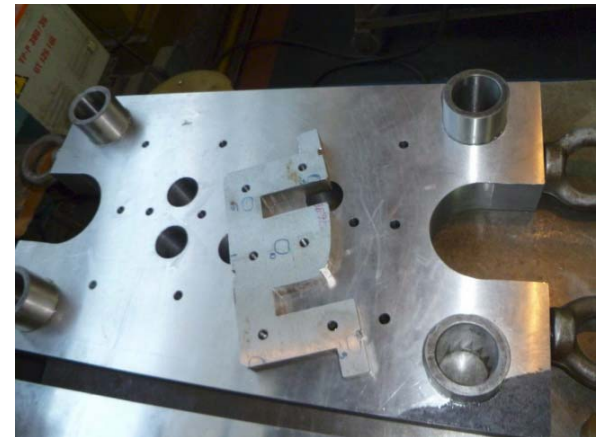


PETRA &-cell 500MHz Cavity



Injector Status

- Injector **Building** Ready July 28, 2011
- **LINAC** Turn Key Contract Award April 2010 (RI)
Design Complete
production of components in progress
Frontend Delivery: June 2011
LINAC Delivery and start Installation August 2011
- **Booster** Semi-turnkey Contract Award: May 2010 (BINP)
Design Finalized, Prototypes of components being produced
Booster Installation : Spring 2012



Critical Subsystems with Novel Features

Magnet Systems

- high field quality,
- micron mechanical reproducibility,
- 30 micron alignment tolerance
- 25 nm mechanical stability

RF

- High Beam loading,
- High RF phase stability
- bunch lengthening

Instrumentation

- Sub-micrometer BPM
- Pico-meter emittance measurements

Controls

- High speed real time deterministic data communication
- Integrated high level controls
- Integrated equipment database

Power Supplies and Electronics

- High reliability

Insertion Devices

- high field quality
- novel materials

Magnet Field Quality

Medium energy (3GeV) + High intensity (500mA) + low emittance (<1nm, 8pm) beam

➔ Lifetime strongly dominated by Touschek effect

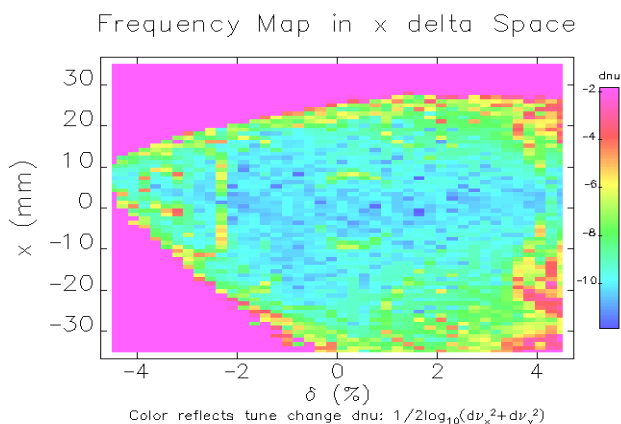
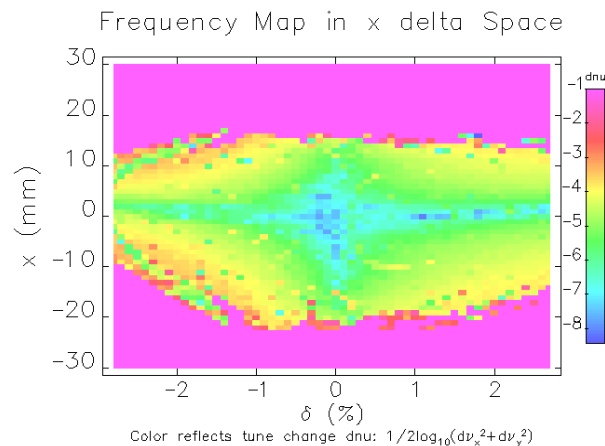
Low emittance lattice with moderate chromaticity and highly optimized sextupole fields

(3 chromatic families, 6 families for nonlinear optimization)

➔ Dynamic aperture fair: 15 mm x 3 mm @ 2.5% momentum deviation @ $\tau_{\text{Touschek}} = 3$ hrs

• Large Dynamic Aperture shrinks for quadrupole and sextupoles with “normal field quality

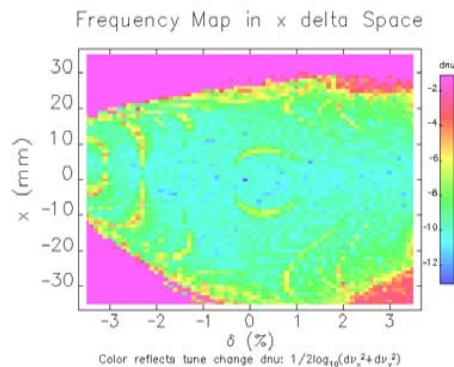
➔ small field errors required: systematic errors $\Delta B/B = 10^{-4}$, nonsystematic $\Delta B/B = 10^{-5}$ @ 25mm



Allowed Relative Field Error Quadrupoles @ $r=25, \times 10^{-4}$

n	Normal Aperture		Large Aperture	
	norm	skew	norm	skew
Symmetry-allowed				
6	3	0	0.5	0
10	3	0	0.5	0
14	3	0	0.1	0
Symmetry-unallowed				
3	2	2	3	1.5
4	2	1	2	1
5	1	1	0.3	0.1
6	-	1	-	0.1
7-9	1	1	0.1	0.1
10	-	1	-	0.1
14	-	1	-	0.1
11-13,15	0.5	0.5	0.1	0.1

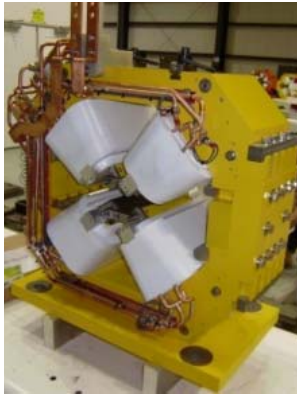
Need 90mm aperture quads in center of achromate



Storage Ring Magnet Systems

based on successful prototypes

**Normal
Quadrupole
Magnet** 120
Units to be built
by BINP



**Wide
Quadrupole**
120 Units to be
built by TESLA
Ltd



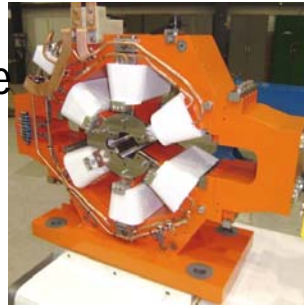
156mm and 100
mm DC dipole
correctors (192
units) to be built
by Everson
Tesla



**Normal
Sextupole**
169 Units to
be built by
Danfysik

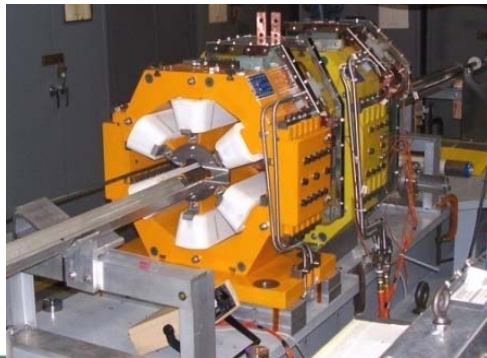


Wide Sextupole
75 Units to be
built by IHEP



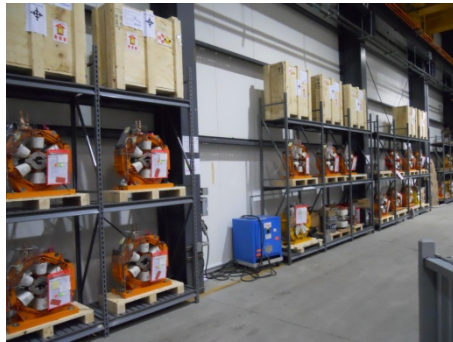
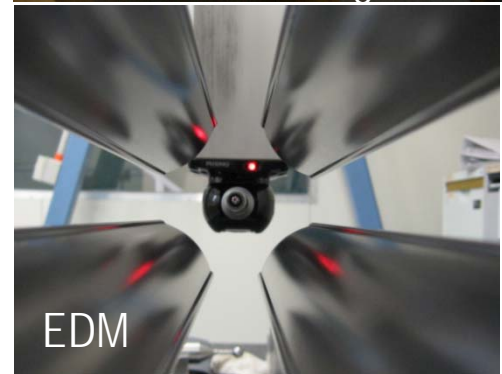
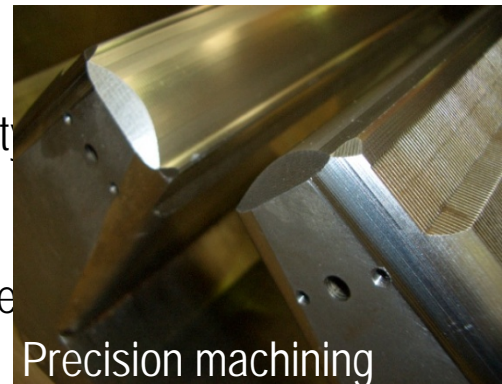
Dipoles 54 units 35 mm
gap and 6 units with
90mm gap to be built by
Buckley

30 large aperture
sextupoles and 60 large
aperture quadrupoles
To be built by Buckley
Industries

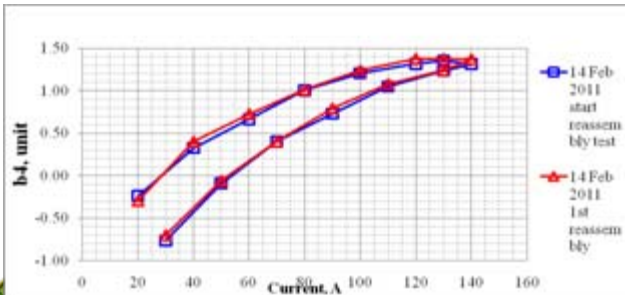


Magnet Production

- 7 Contracts awarded in Fall 2009
- All manufacturers made large effort to meet high and reproducible field quality
- ~ 6-12 months development needed before production could start
- Advanced Production methods provide **10 micron precision** of pole structure and **3 micron mechanical reproducibility**
- Magnet production is taking off and ~15% of production is completed



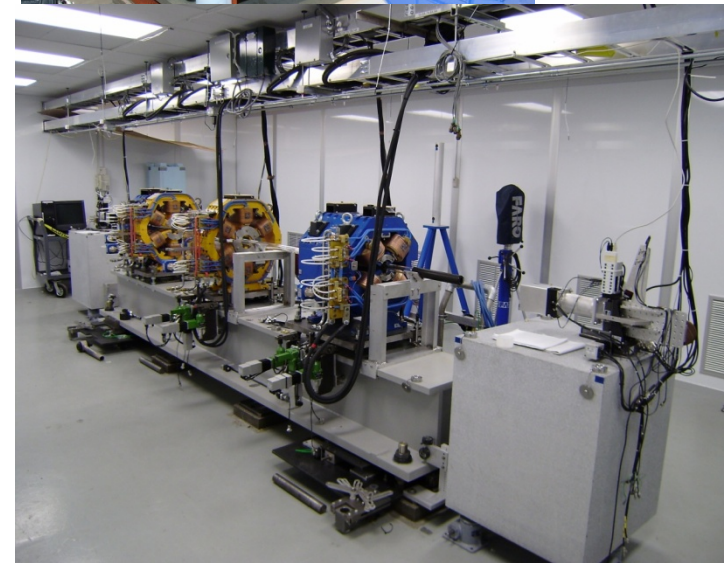
Magnet acceptance Testing at BNL



Remarkable reproducibility after de-assembly-reassembly

Girder, Supports and Integration

- Girder girders have been designed and manufactured for low vibration response ($f_{res} > 30\text{Hz}$) and high thermal stability
- Visco-elastic layers in supports are an important feature
- A precision alignment procedure based on stretched wire with AC current was developed which allows to measure magnet center with $5\ \mu\text{m}$ precision
- Intricate procedure to align the magnet and secure high precision alignment while girders are transported and installed developed
- Alignment performed in temperature controlled enclosure Which mimics tunnel conditions
- Procedure fully tested
- First girder equipped with magnets, vacuum components and diagnostic equipment



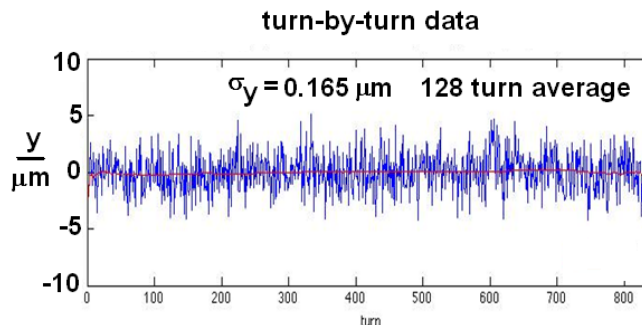
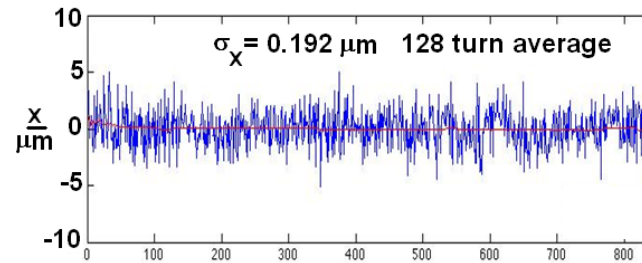
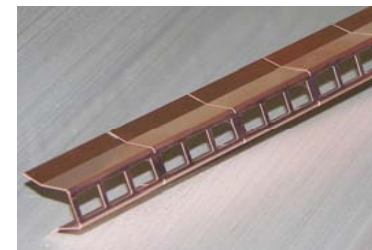
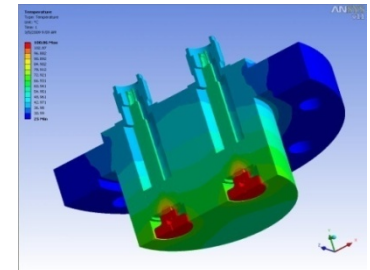
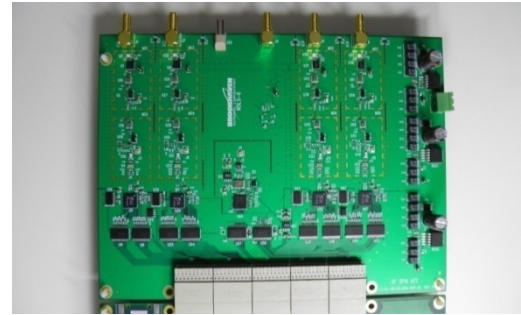
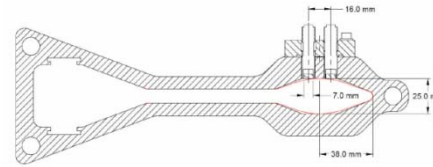
*Environmental Room ($\Delta T < 0.1\ \text{C}$)
for $30\ \mu\text{m}$ Precision Alignment*

First Fully Integrated NSLS-II Magnet Girders



Instrumentation-BPM System

- New improved Button Monitor, Boron-Nitride Heat distribution washers avoid beam heating issues
- In-house development BPM electronics. 500MHz band pass filter, sampling at 117MHz, pilot tone mixed with beam signal for continuous relative calibration of channels
- Beam test at ALS confirm: meet demanding NSLS-II requirements resolution $0.2 \mu\text{m}$, stability $0.2 \mu\text{m}$)
- Detrimental TE (H) modes in keyhole-shaped beam pipe exited by beam
➔ RF shield separates beam- from ante-chamber

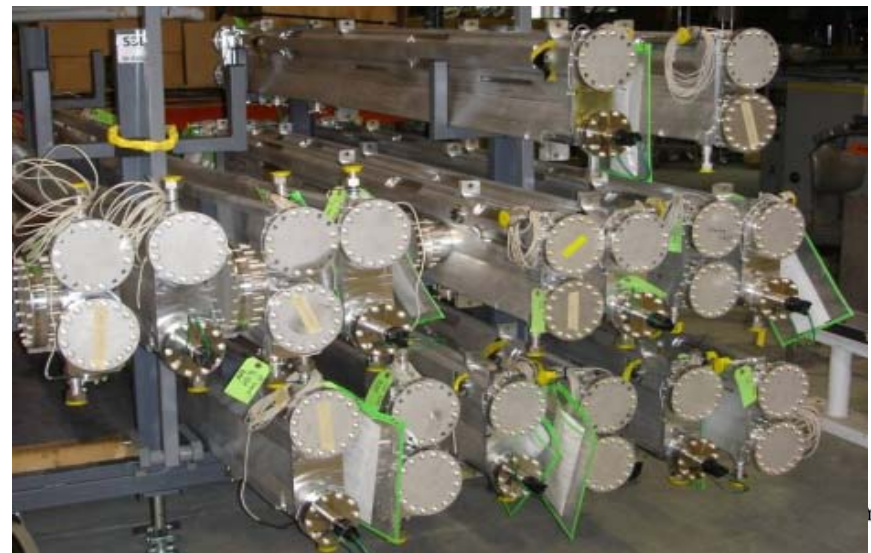
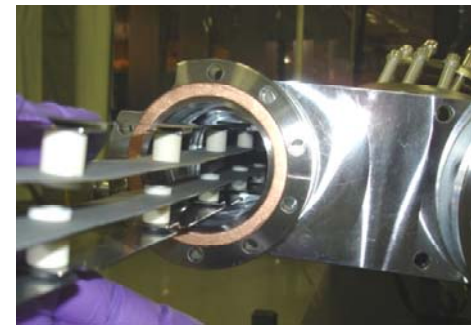
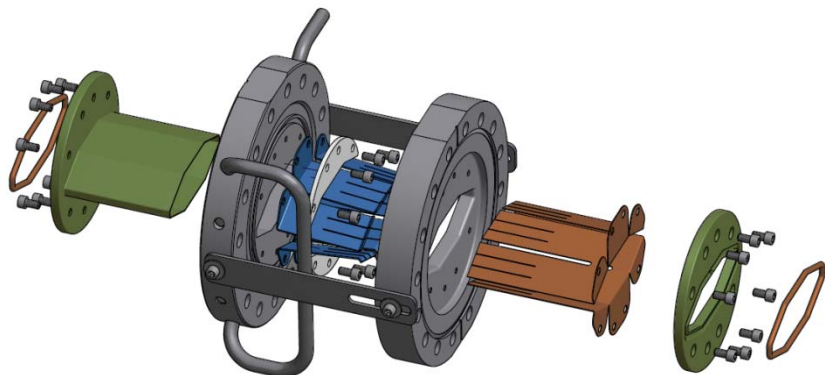


Vacuum System

- Vacuum System Based on extruded Aluminum
- Multistage production with final integration in-house
- Status: ~1/3 of chambers ready for installation



- Glidcop masks absorb synchrotron radiation
- New Design Shielded Bellow, Ag+Rh coated sleeves
- First Units being manufactured in-house



Storage Ring RF

Requirements

	Baseline Capability with 2 RF Cavity Systems Required Voltage 3.3 MV		Fully Build-out Capability with 4 RF Cavity Systems Required Voltage 5 MV	
	#	P(kW)	#	P(kW)
Dipole	60	144	60	144
Damping wiggler	3 (21 m)	259	8 (56m)	517
Cryogenic-PMU	3	76	6	127
E_l IVU	2	33	4	66
Additional devices	~7	120	~10	200
TOTAL		529		1003
Available RF Power		540		1080

RF Stability Requirements

	$\Delta\phi$ (deg)	$d\delta$ ($\times 10^{-4}$)
Centroid jitter due to Residual dispersion (ID's)	0.81	3
Vertical Divergence (from momentum jitter)	2.4	9
Dipole, TPW (position stability due to momentum jitter)	0.27	1
Timing experiments (5% of 15ps bunch @>500Hz)	0.14	0.5

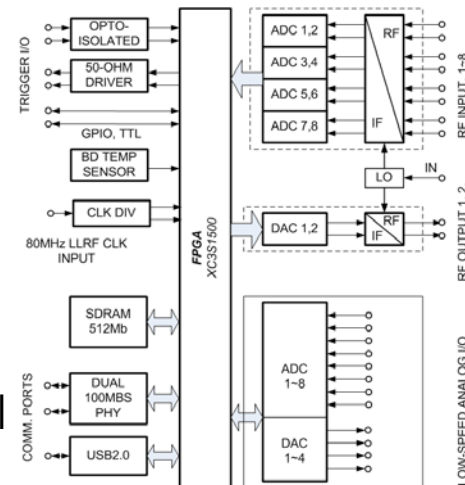
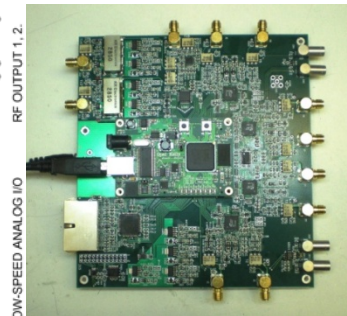
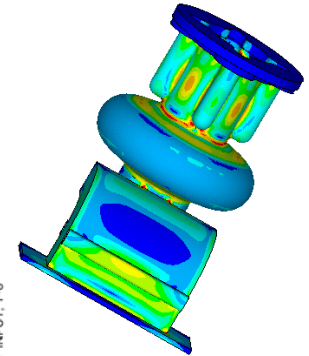
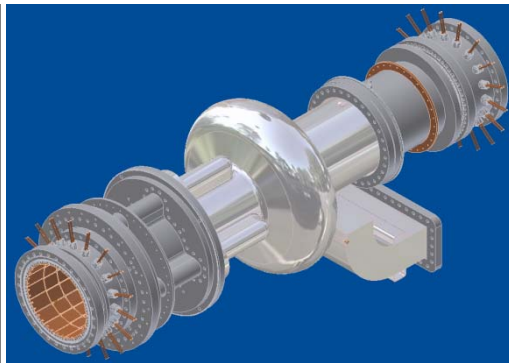
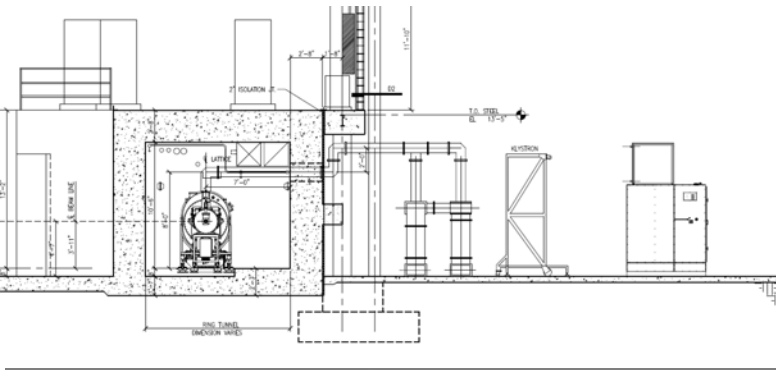
Cavities: Superconducting single cell 500MHz Cavities

Reasons: more economic on the long term, better beam loading performance

RF Power Source: Klystron Amplifiers 310kW

Passive superconducting 3rd harmonic cavity for bunch lengthening

Storage Ring RF System



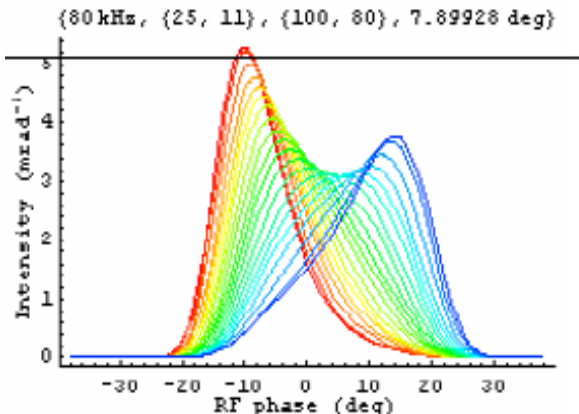
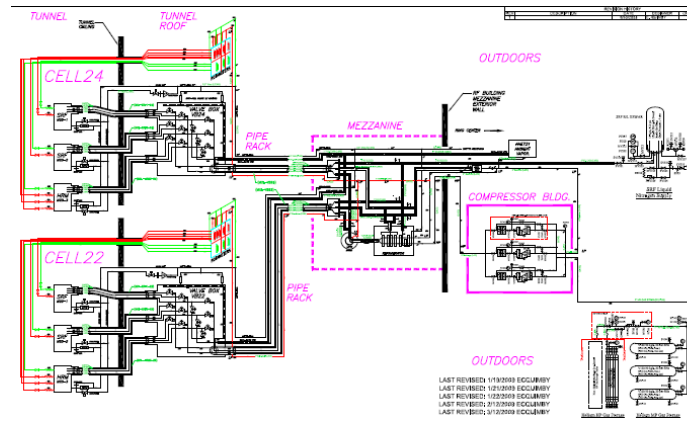
- **Single cell 500 MHz SC Cavity: CESR-B Design**
 - Updated design to comply with safety regulations,
 - Input coupler adaption
- **310 kW klystron RF transmitter,**
 - Turn-key, - in production
- **In-house development LLRF Controls**
 - FPGA based control module, designed, fabricated, tests performed
 - Extensive LLRF modeling,
 - Future option for adaptive feedback for optimized control

RF Systems

Lq He Cryogenic Plant
900W lq. He Plant
Turn-key system in production

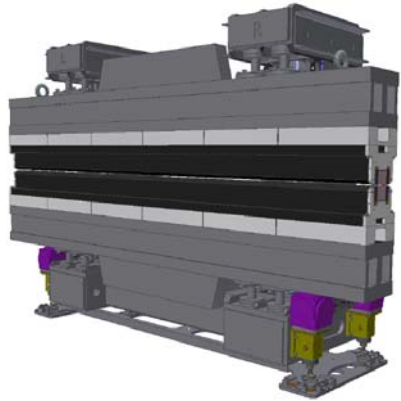
3rd Harmonic Cavity

- Bunch lengthening factor 2-3
- Margin for Touschek lifetime
- New design
- Production in collaboration with Industry (SBIR)
- Low power test successful

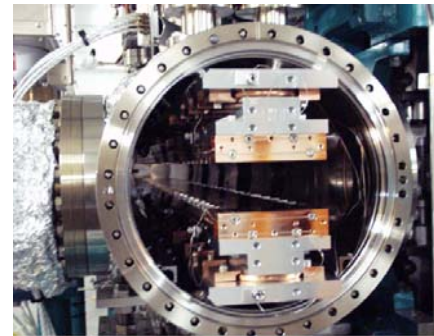


Insertion Devices

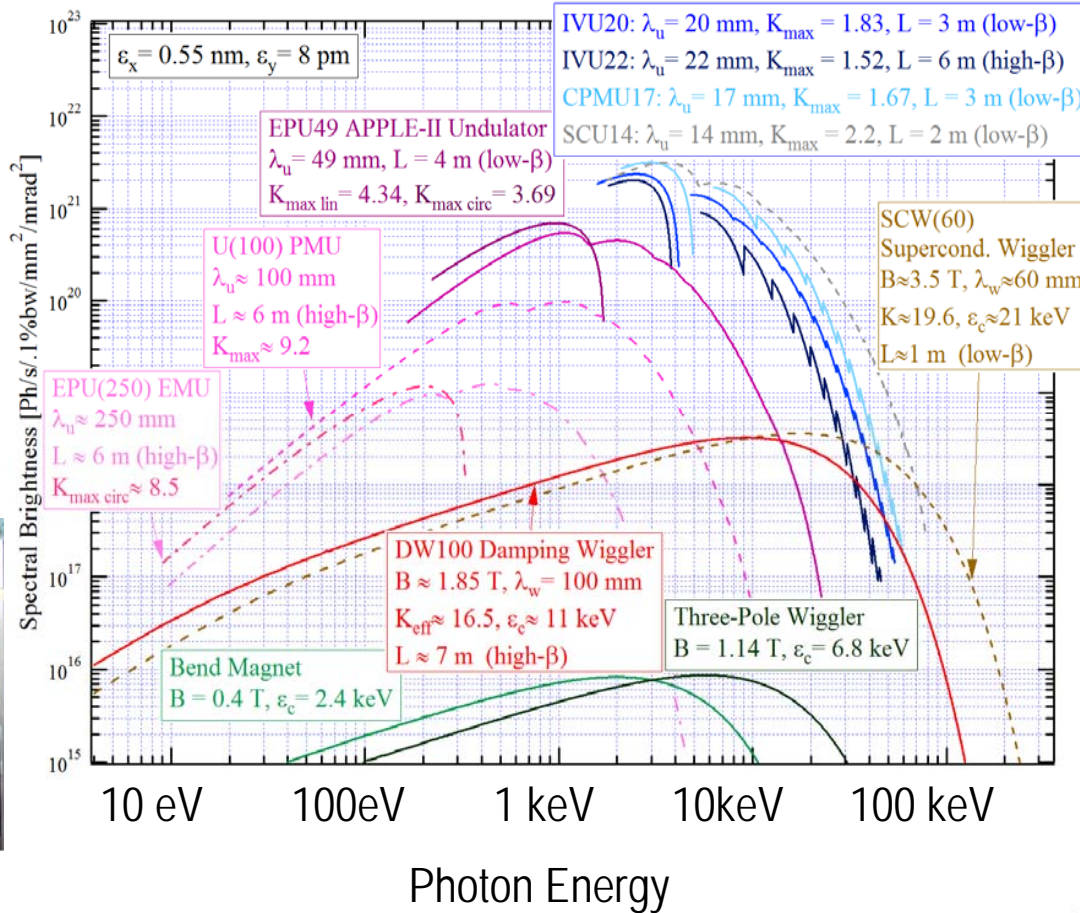
Damping Wiggler 1.8T
6 x 3.5m in production



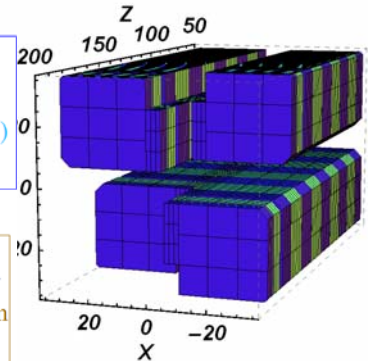
IVU 20,21,22
Design complete



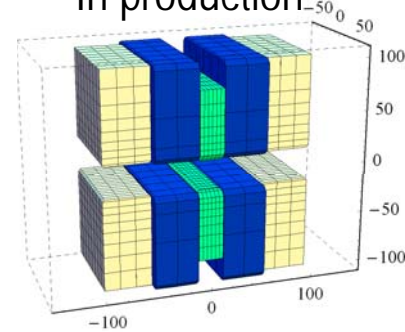
Brightness of NSLS-II radiation devices



EPU
contract award



3 Pole Wiggler
In production



NSLS-II Insertion Devices

Name	U20	U22(IXS)	EU49	U21(SRX)	DW-1.8T	3PW
Type	IVU	IVU	EPU	IVU	PMW	PMW
Photon energy range	Hard x-ray (1.9-20keV)	Hard x-ray (9.1keV)	Soft x-ray (250eV-1.7keV)	Hard x-ray (1.9-20keV)	Broad band (<10eV-100keV)	Broad band (<10eV-100keV)
Type of straight section	Short	Long	Short (canted)	Short (canted)	Long (in-line)	near 2 nd Dipole
Period length (mm)	20	22	49	21	100	-
Length (m) & Number of Devices	3.0 x 2	3.0	2.0 x 2	1.5	3.5 x 6	0.25
Number of periods	148	135	36 x 2	69	34 x 2	0.5
Magnetic gap (mm)	5	7.0	11.5	5.5	15.0	28
Peak magnetic field strength B (T)	1.03	0.78	0.57(Heli) 0.94 (Lin) 0.72(vlin) 0.41 (45°)	0.9	1.80	1.14
Keff	1.81	1.52	2.6(Heli) 4.3 (Lin) 3.2(vlin) 1.8 (45°)	1.79	18.0	-
hν fundamental, eV	1620	1802	230 (Heli) 180 (Lin) 285(vlin) 400 (45°)	1570		
hν critical, keV					10.7	6.8
Total power (kW)	8.0	4.7	8.8	3.6	64.5	0.32

Insertion Devices-New Materials

Successful Tests with Pr-Fe-B

Will be operated at

Lq N2 temperature,

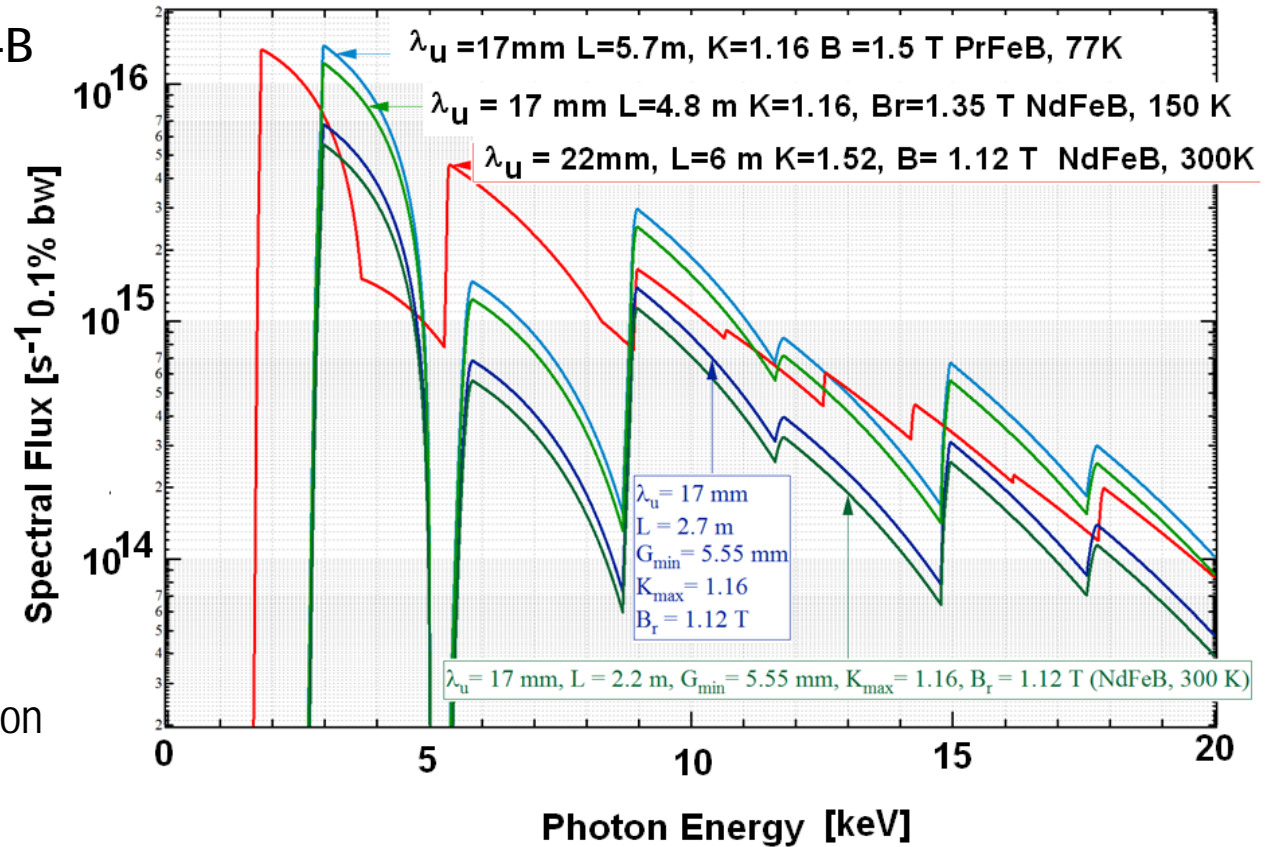
Fairly flat temperature coefficients

➔ Stable operation with enhanced B_r

Vacuum bakeout tests in

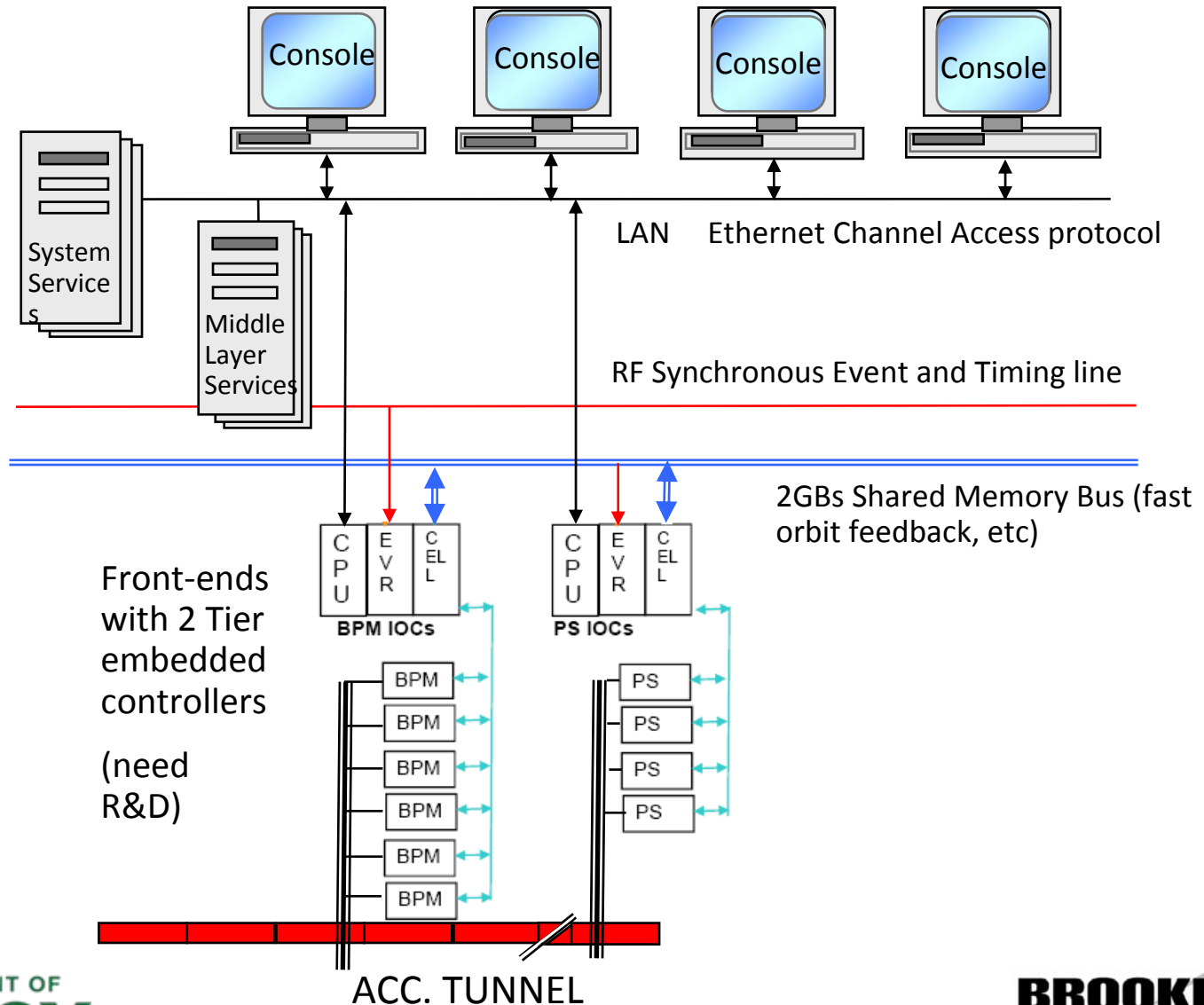
Progress

Magnet test array in production



Control System

EPICS
protocol



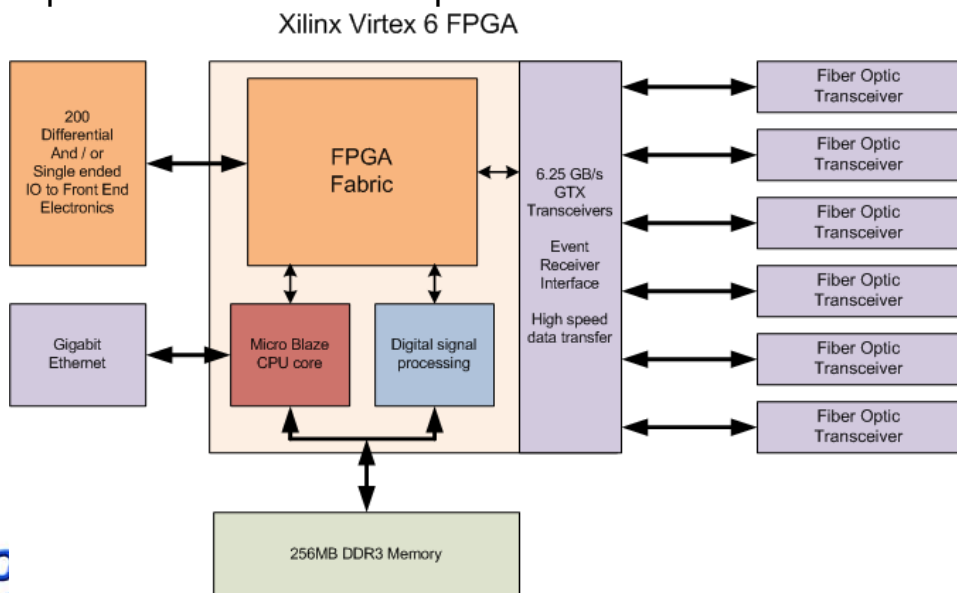
Digital Front End Electronics

BPM Application:

- Calculates beam position from Raw ADC inputs at 117MHz
- Stores **1 million** Turn By Turn data points, 10KHz data points **and** raw ADC measurements
- Provides 10kHz position data for Fast Orbit Feedback

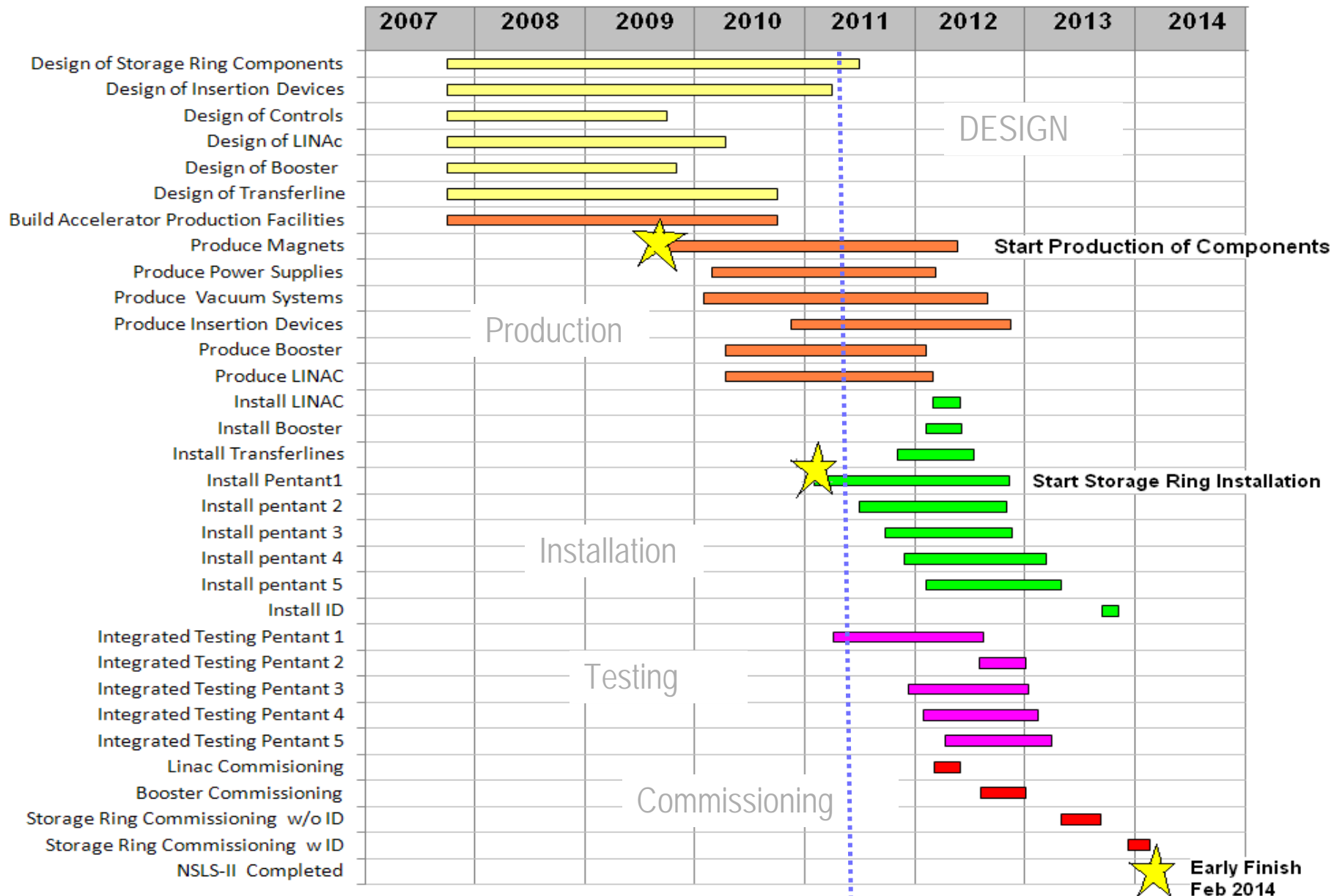
Cell Controller Application:

- Transfers all BPM measurements to all cells in less than 15us over redundant fiber optics
- Computes 90 parallel Eigenvectors in less than 4us for fast orbit feedback
- Responds to beam envelope violations in less than 100us for machine protection

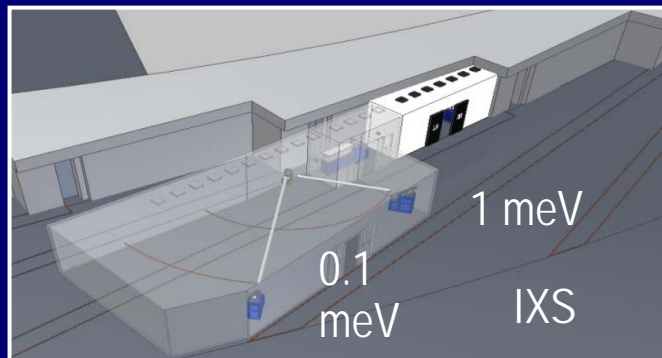


- High speed Serial Communication
- Gigabit Ethernet
- Large Memory
- On board CPU
- Digital Signal Processing

Accelerator Schedule

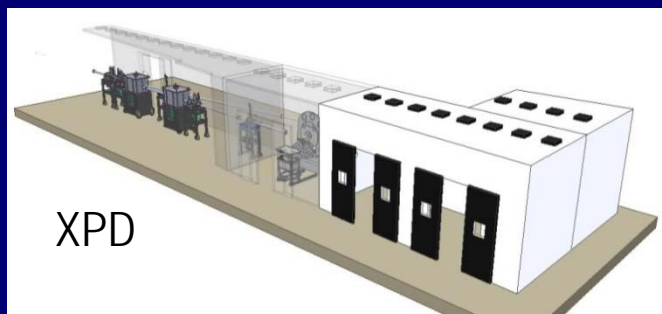
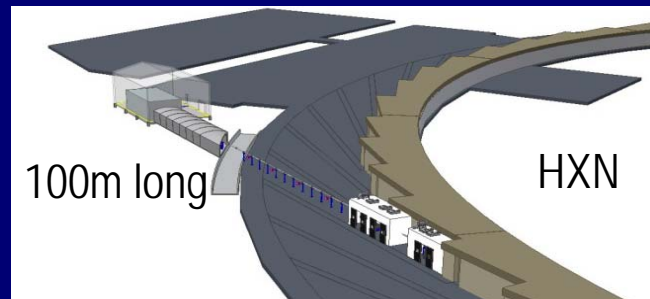


The Six Initial NSLS-II Beamlines



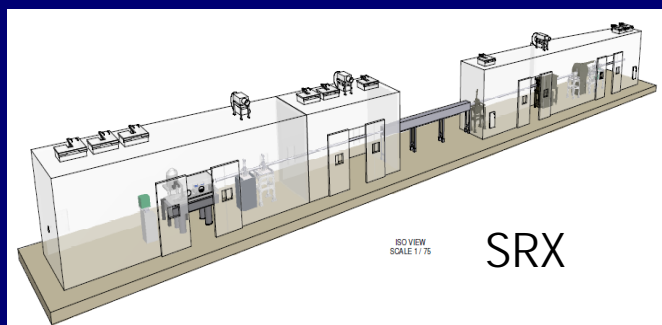
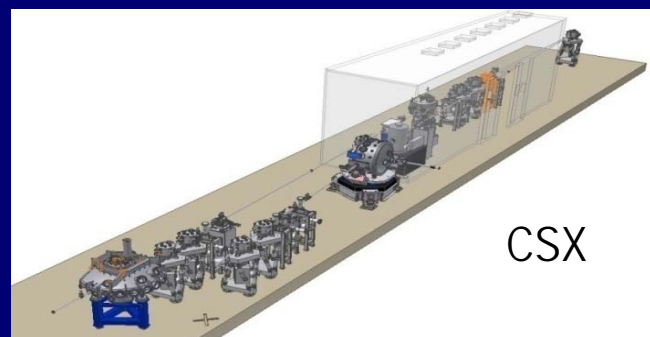
inelastic
x-ray scattering

hard x-ray
nanoprobe



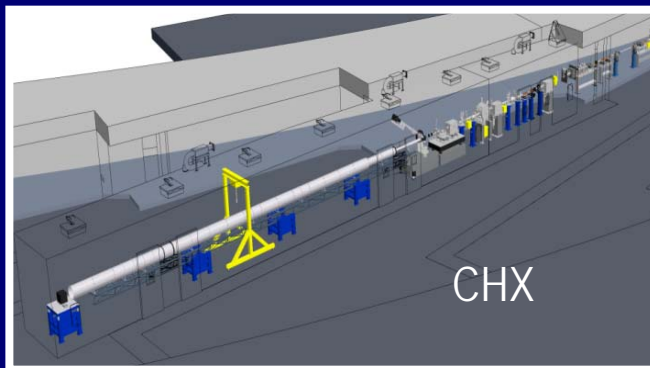
x-ray powder
diffraction

coherent soft x-ray
scattering/polarization



sub- μm resolution
x-ray spectroscopy

coherent hard
x-ray scattering



Conclusion

- NSLS-II is a 3rd generation light source using cutting edge accelerator technology

- Magnet production
- Alignment
- instrumentation
- Insertion devices
- Controls

to meet the desired performance, a brightness of 10^{21} 2keV photons per (mm²mrad²sec,0,1%bw) needed to achieve 1nm spatial resolution and 0.1meV energy resolution

- Most of Accelerator Components are in production
- First Part of Ring Building available for installation
- Installation of components has started
- Linac will be installed and commissioned this year
- Storage Ring Commissioning will start in May 2013
- Project Early completion is envisioned for February 2014

NSLS-II PAC'11 Contributions

<u>Lattice Design:</u>	THP189, THP190, THP129,
<u>Accelerator Physics:</u>	WEP176, MOP192, WEP217, THP127, THP193, MOP276
<u>Safety Systems:</u>	MOP274,
<u>RF:</u>	FROBS4, TUP055,
<u>Instrumentation:</u>	MOP211, MOP199, MOP198, MOP193, MOP266
<u>Controls:</u>	WEODN4, MOP165
<u>Injection systems:</u>	TUP211, THP131-135, THP215, WEP282-283
<u>Insertion Devices:</u>	THOPS4,
<u>Vacuum:</u>	THP216